PATENT ASSIGNMENT

Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE: NEW ASSIGNMENT

NATURE OF CONVEYANCE: CHANGE OF NAME

CONVEYING PARTY DATA

Name	Execution Date
VLSI Technology, Inc.	07/02/1999

RECEIVING PARTY DATA

Name:	Philips Semiconductors VLSI Inc.
Street Address:	1251 Avenue of the Americas
City:	New York
State/Country:	NEW YORK
Postal Code:	10020

PROPERTY NUMBERS Total: 1

Property Type	Number
Patent Number:	6418875

CORRESPONDENCE DATA

Fax Number: (408)518-5671 Phone: 3474431592

Email: david.schaeffer@nxp.com

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent

via US Mail.

Correspondent Name: David L. Schaeffer

Address Line 1: 411 East Plumeria Drive, MS41
Address Line 2: NXP Semiconductors, IP&L
Address Line 4: San Jose, CALIFORNIA 95134

NAME OF SUBMITTER:

David L. Schaeffer

Total Attachments: 3

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PATENT REEL: 027138 FRAME: 0676 840.00 641887

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APPENDIX

SECRETARY'S CERTIFICATE

I, W. T. OATES, JR., Secretary of Philips Semiconductors Inc., do hereby certify:

- that attached is a true and correct copy of Certificate of Amendment of Certificate of Incorporation as filed with the Secretary of State of the State of Delaware on July 2, 1999 changing the name of VLSI Technology, Inc. to Philips Semiconductors VLSI Inc.
- 2. that attached is a true and correct copy of Ccrtificate of Merger merging Philips Semiconductors Inc. into Philips Semiconductors VLSI Inc. and change of name of survivor Philips Semiconductors VLSI Inc. to Philips Semiconductors Inc. as filed with the Secretary of State of the State of Delaware on December 29, 1999.

IN WITNESS WIEREOF, I have hereunto set my hand and affixed the Corporate Seal on May 17, 2000.

Secretary

PATENT REEL: 013781AFEAME: 0972 REEL: 027138 FRAME: 0677

State of Delaware Office of the Secretary of State PAGE 1

I, EDWARD J. FREEL, SECRETARY OF STATE OF THE STATE OF DELAWARE, DO HEREBY CERTIFY THE ATTACHED IS A TRUE AND CORRECT COPY OF THE CERTIFICATE OF AMENDMENT OF "VLSI TECHNOLOGY, INC.", CHANGING ITS NAME FROM "VLSI TECHNOLOGY, INC." TO "PHILIPS SEMICONDUCTORS VLSI INC.", FILED IN THIS OFFICE ON THE SECOND DAY OF JULY, A.D. 1999, AT 9 O'CLOCK A.M.

A FILED COPY OF THIS CERTIFICATE HAS BEEN FORNARDED TO THE NEW CASTLE COUNTY RECORDER OF DEEDS.

Edward I. Freel, Secretary of State

AUTHENTICATION:

9846969

DATE:

07-02-99

2125539 8100

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PATENT

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STATE OF DELAMARE
SECRETARY OF STATE
DIVISION OF CORPORATIONS
FILED 09:00 AM 07/02/1999
991273471 - 2125539

CERTIFICATE OF AMENDMENT OF CERTIFICATE OF INCORPORATION

VLSI Technology, Inc., a corporation organized and existing under and by virtue of the General Corporation Law of the State of Delaware, DOES HEREBY CERTIFY:

FIRST: That the Board of Directors of VLSI Technology, Inc., by unanimous written consent of its members, filled with the minutes of the board, duly adopted resolutions setting forth a proposed emendment to the Certificate of Incorporation of said corporation, declaring said amendment to be advisable:

RESOLVED, that the Certificate of incorporation of this Corporation be amended by changing the first Article thereof so that, as amended, said Article shall be and read as follows:

"FIRST. The name of the Corporation is PHILIPS SEMICONDUCTORS VLSI INC."

SECOND: That in lieu of a meeting and vote of stockholders, the stockholders have given unanimous written consent to said amendment in accordance with the provisions of Section 228 of the General Corporation of the State of Delaware.

THIRD: That the aforesaid amendment was duly adopted in accordance with the applicable provisions of Section 242 and 228 of the General Corporation Law of the State of Delaware.

IN WITNESS WHEREOF, said VLSI Technology, Inc. has caused this certificate to be signed by Paul S. Friedlander, its Vice President and attested by Warren T. Oates, Jr., its Assistant Secretary this 2nd day of July, 1999.

VLSI TECHNOLOGY, INC.

Vice President

ATTEST:

Assistant Secretary

PATENT

REEL: 013784AFRAME: 0977

REEL: 027138 FRAME: 0679

RECORDED: 02/24/2003 RECORDED: 10/28/2011